



NIT-288

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

N. KOFUJI et al

Serial No. 09/920,834

Group Art Unit: 1765

Filed: August 3, 2001

Examiner: K. C. Chen

For: METHOD AND APPARATUS FOR FABRICATING  
SEMICONDUCTOR DEVICES

AMENDMENT

RECEIVED  
NOV 03 2003  
TC 1700

Commissioner for Patents  
Alexandria, VA 22313

Sir:

In response to the Office Action dated July 30, 2003,  
please amend the above-identified application as follows.